

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 12, 2024

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

LG642493134

LABORATORY GROWN DIAMOND

CUSHION BRILLIANT

8.35 X 5.98 X 4.02 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

1.58 CARAT

D

VS 1

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

EXCELLENT

EXCELLENT

NONE

INSCRIPTION(S)

COMMENTS: THIS LABORATORY GROWN DIAMOND WAS CREATED BY CHEMICAL VAPOR DEPOSITION (CVD) GROWTH PROCESS. TYPE IIA

IGI LG642493134

PROPORTIONS

Medium To Slightly Thick (Faceted)


14.5%

50%

59%

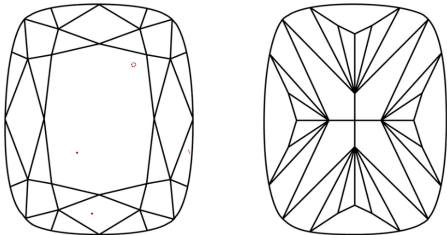
67.2%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless



Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI



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IGI



July 12, 2024

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CUSHION BRILLIANT

8.35 X 5.98 X 4.02 MM

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.58 CARAT

D

VS 1

67.2%

59%

EXCELLENT

EXCELLENT

NONE

IGI LG642493134

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